

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: KEVIN L. BEAMAN ET AL.  
APPLICATION No.: 10/733,523  
FILED: DECEMBER 10, 2003  
FOR: **METHODS AND SYSTEMS FOR  
CONTROLLING TEMPERATURE  
DURING MICROFEATURE WORKPIECE  
PROCESSING, E.G., CVD DEPOSITION**

EXAMINER: DAVID P. TUROCY  
ART UNIT: 1762  
CONF. NO: 9060

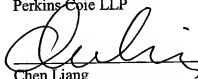
**Comments on Statement of Reasons for Allowance**

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In the Notice of Allowability mailed May 23, 2007, the Examiner allowed claims 1-15, 27-34, and 40-43. Although the applicants' attorney agrees with the Examiner's conclusion that these claims are allowable, the applicants' attorney notes that the claims may be allowable for reasons other than those identified by the Examiner and does not concede that the Examiner's characterizations of the terms of the claims and the prior art are correct.

Respectfully submitted,  
Perkins Coie LLP



Chen Liang  
Registration No. 51,945

Date: July 12, 2007

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